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Attorney Docket No. 0756-2027

Serial No. Not Yet Assigned

**INFORMATION DISCLOSURE STATEMENT**

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI et al.

Filing Date: September 15, 1999

Group: 4772-1200

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
W	5,640,292	6/17/97	Schultz et al.	360	125	
W	5,718,949	2/17/98	Schultz et al.	427	249	
W	5,637,373	6/10/87	Hayashi	428	65.3	
W	5,275,850	1/4/94	Kitoh et al.	427	577	
W	<del>5,226,409</del> 5,266,409	11/30/93	Schmidt et al.	428	446	
W	5,645,900	7/8/97	Ong et al.	428	571	
W	5,569,502	10/20/96	Koinuma et al.	427	606	
W	5,360,483	11/1/94	Kurokawa et al.	118	723E	
W	5,110,437	5/5/92	Yamada et al.	204	298.33	
W	4,534,816	8/13/85	Chen et al.	156	345	
	<del>5,123,376</del>	<del>6/23/92</del>	<del>Kaneko et al.</del>			<del>Dupl. to</del>
W	5,203,924	4/20/93	Mitani et al.	118	719	
W	5,224,411	7/8/93	Felts et al.	118	718	
W	4,987,856	1/29/91	Heyer Hey et al.	118	715	
W	4,438,723	3/27/84	Cannella et al.	118	718	
W	4,871,581	10/3/89	Yamazaki	118	723	
W	5,123,376	6/23/92	Kaneko et al.	118	718	
W	4,995,341	2/26/91	Matsuyama	118	723	
W	5,521,427	6/22/93	Koinuma et al.	156	345	

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Date Considered

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Applicant: Shunpei YAMAZAKI et al.

Filing Dat : Septembe4r 15, 1999

Gr up: 4773-1256

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)

**FOREIGN PATENT DOCUMENTS**

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	<del>58-42472</del>	<del>3/11/93</del>	<del>Japan</del>			<del>Full</del>	
	<del>2-83816</del>	<del>3/28/90</del>	<del>Japan</del>			<del>Full</del>	
	<del>1-226711</del>	<del>9/11/89</del>	<del>Japan</del>			<del>Full</del>	
	<del>2-125877</del>	<del>5/14/90</del>	<del>Japan</del>			<del>Full</del>	
<i>W</i>	3-247769	11/5/91	Japan			Abstract	
	<del>62-262418</del>	<del>11/14/87</del>	<del>Japan</del>			<del>Abstract</del>	

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>W</i>	J.W. Coburn, "Plasma Etching and Reactive Ion Etching", AVS Monograph Series, 1982, pages 6-11.

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